

<b>Notice of References Cited</b>	Application/Control No. 10/724,735		Applicant(s)/Patent Under Reexamination LIN, SHENG-HSIUNG	
	Examiner Noah C. Hawk		Art Unit 3637	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,421,543 A	06-1995	Rossman et al.	248/118.3
*	B	US-5,547,154 A	08-1996	Kirchhoff et al.	248/118.3
*	C	US-5,542,637 A	08-1996	Schriner, Michael J.	248/346.01
*	D	US-5,641,369 A	06-1997	Kirchhoff et al.	156/73.1
*	E	US-5,704,698 A	01-1998	Lin, Chin-Chih	312/208.1
*	F	US-5,713,544 A	02-1998	Wolf et al.	248/118
*	G	US-5,771,814 A	06-1998	Clausen, Eivind	108/93
*	H	US-5,826,840 A	10-1998	Yun, Je-Ho	248/118
*	I	US-6,164,213 A	12-2000	Topps et al.	108/43
*	J	US-6,349,915 B1	02-2002	Jones et al.	248/442.2
*	K	US-6,454,369 B1	09-2002	Cooper et al.	312/223.3
*	L	US-2004/0140742 A1	07-2004	Liu, Jan Ban	312/291
*	M	US-6,796,735 B2	09-2004	Lin, Kenny	400/472

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.